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Sir:

☒ No additional fee for submission of an IDS is required.

☐ The fee of \$240.00 as set forth in 37 C.F.R. § 1.17(p) is also enclosed.

☐ A certification under 37 C.F.R. § 1.97(e) is also enclosed.

☐ A certification under 37 C.F.R. § 1.97(e), a petition requesting consideration of the information disclosure statement, and the petition fee of \$130.00 as set forth in 37 C.F.R. § 1.17(i) are also enclosed.

☐ Charge \$\_\_\_\_\_ to Deposit Account No. 02-4800 for the fee due.

☐ A check in the amount of \$\_\_\_\_\_ is enclosed for the fee due.

Information Disclosure Statement Transmittal Letter

Application No. 09/348,816

Attorney's Docket No. 018773-022

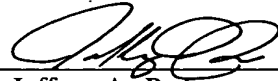
Page 2

The Commissioner is hereby authorized to charge any appropriate fees under 37 C.F.R. §§ 1.16, 1.17 and 1.21 that may be required by this paper, and to credit any overpayment, to Deposit Account No. 02-4800. This paper is submitted in triplicate.

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

By: \_\_\_\_\_



Jeffrey A. Pade

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Date: September 29, 1999



Patent  
Attorney's Docket No. 018773-022

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of )  
Takashi KOBAYASHI et al. )  
Application No.: 09/348,816 ) Group Art Unit: 3743  
Filed: July 8, 1999 ) Examiner: Unassigned  
For: AN EVAPORATOR, A HEAT )  
ABSORBER, A THERMAL )  
TRANSPORT SYSTEM AND A )  
THERMAL TRANSPORT METHOD )

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**INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited is enclosed.

Japanese Patent Publication No. SHO 58-145889, August 31, 1983 (Abstract only);

Japanese Patent Publication No. SHO 60-23784, February 6, 1985 (Abstract only);

Japanese Patent Publication No. SHO 62-172188, July 29, 1987 (Abstract only);

Japanese Patent Publication No. SHO 62-252892, November 4, 1987 (Abstract only);

Japanese Patent Publication No. HEI 06-185883, July 8, 1994 (Abstract only);

KOTLYAROV, E.Y., et al., "Methods of Increase of the Evaporators Reliability for Loop Heat Pipes and Capillary Pumped Loops", SAE International, 24<sup>th</sup> International Conference on Environmental Systems and 5<sup>th</sup> European Symposium on Space Environmental Control Systems, Friedrichshafen, Germany, June 20-23, 1994, pps. 1-13; and


KU, J. "Overview of Capillary Pumped Loop Technology", ASME - Heat Pipes and Capillary Pumped Loops, HTD, Vol. 236, 1993, pps. 1-17.

The documents are being submitted within 3 months of the filing or entry of the national stage of this application or before the first Office Action on the merits, whichever is later, therefore no fee or certification is required under 37 C.F.R. § 1.97(b).

To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialled copy of this form be returned to the undersigned.

Respectfully submitted,

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